

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of : **Confirmation No. 4090**
Kazuto HIROKAWA et al. : Docket No. 2003_0960A
Serial No. 10/617,789 : Group Art Unit 3723
Filed July 14, 2003 : Examiner Hadi Shakeri
SUBSTRATE POLISHING APPARATUS : **Mail Stop: Amendment**

AMENDMENT THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 2, 2004, the period for response to which having been extended by one month to April 2, 2005, please amend the above-identified U.S. Patent application as follows: